

S/N09/825,611

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sujit Sharan et al.

Examiner: Evan Pert

Serial No.: 09/825,611

Group Art Unit: 2826

Filed: April 3, 2001

Docket No: 303.930US3

Title: METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

SUPPLEMENTAL AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Further to the Amendment and Response filed on December 16, 2005, Applicant submits the following: